

<b>Notice of References Cited</b>	Application/Control No. 10/801,684		Applicant(s)/Patent Under Reexamination KAWAURA ET AL.	
	Examiner David García Cervetti		Art Unit 2436	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,548,728 A	08-1996	Danknick, Daniel A.	709/213
*	B	US-5,778,070 A	07-1998	Mattison, Phillip E.	713/191
*	C	US-6,023,727 A	02-2000	Barrett et al.	709/221
*	D	US-6,363,463 B1	03-2002	Mattison, Phillip E.	711/164
*	E	US-2003/0037246 A1	02-2003	Goodman et al.	713/191
*	F	US-2003/0050010 A1	03-2003	Fallenstein, Michael John	455/41
*	G	US-2003/0084275 A1	05-2003	David et al.	713/1
*	H	US-6,694,434 B1	02-2004	McGee et al.	713/189
*	I	US-2004/0060044 A1	03-2004	Das et al.	717/171
*	J	US-2004/0042363 A1	03-2004	Kobayashi et al.	369/053.21
*	K	US-2005/0158100 A1	07-2005	Yamaguchi et al.	400/062
*	L	US-6,944,425 B2	09-2005	Fallenstein, Michael John	455/41.2
*	M	US-6,993,650 B2	01-2006	Landers et al.	713/100

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.